

**Application Data Sheet****Application Information**

Application Type:: Regular  
Subject Matter:: Utility  
CD-ROM or CD-R: None  
Title:: METHOD FOR FABRICATING A FE-SI BASED  
THIN FILM, AND FE-SI BASED THIN FILM  
Attorney Docket Number:: 118365  
Suggested Drawing Figure::  
Total Drawing Sheets:: 4  
Small Entity:: Yes

**Applicant Information**

Applicant Authority type:: Inventor  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: Hiroshi  
Family Name:: FUNAKUBO  
City of Residence:: Kawasaki City  
Country of Residence:: JAPAN

**Correspondence Information**

Correspondence Customer Number:: 25944

| Foreign Priority Information |                      |                               |                    |
|------------------------------|----------------------|-------------------------------|--------------------|
| Country::                    | Application Number:: | Filing Date::                 | Priority Claimed:: |
| JAPAN                        | 2003-106784          | 4/10/2003                     | Yes                |
| Assignee Information         |                      |                               |                    |
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